

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
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 MAEKAWA et al.)
)
 Serial No.: 10/827,457)
)
 Filed: April 19, 2004)
)
 For: Method For Forming Pattern And)
 Drop Discharge Apparatus)
)
 Examiner: Marianne L. Padgett)
)
 Art Unit: 1762)
)
 Confirmation No.: 2984)

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT B

Applicants have the following response to the Office Action of November 7, 2006, a two month extension of time being submitted herewith.

Please amend the above-identified application as follows: